



PATENT APPLICATION

RCE/2817
IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasushi YAMASAKI et al.

Group Art Unit: 2811

Application No.: 09/970,766

Examiner: S. Hu

Filed: October 5, 2001

Docket No.: 110791

For: METHOD OF MANUFACTURING
SEMICONDUCTOR SUBSTRATE,
SEMICONDUCTOR SUBSTRATE, ELECTRO-
OPTICAL APPARATUS AND ELECTRONIC
EQUIPMENT

MAIL STOP RCE

**LARGE ENTITY REQUEST FOR
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicants hereby request continued examination.

☒ Applicants further request entry and consideration of the Amendment After Final Rejection filed July 21, 2004.

☒ Applicants also further request entry and consideration of the attached Supplemental Amendment.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 157554 in the amount of ☒ \$770.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,

Leana Levin

James A. Oliff
Registration No. 27,075

Leana Levin
Registration No. 51,939

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01 FC:1801

770.00 DP

JAO:LL/lxl

Date: August 23, 2004

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DEPOSIT ACCOUNT USE
AUTHORIZATION
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